



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/705,773

Filing Date: November 11, 2003

Applicants: Nakamura et al.

Group Art Unit: 3752

Examiner: Christopher S. Kim

Title: METHOD OF, AND APPARATUS FOR, SUCKING FUNCTION
LIQUID DROPLET EJECTION HEAD; LIQUID DROPLET
EJECTION APPARATUS; METHOD OF MANUFACTURING
ELECTROOPTIC DEVICE; ELECTROOPTIC DEVICE; AND
ELECTRONIC EQUIPMENT

Attorney Docket: 9319H-000587

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Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENT/REPLY

Sir:

In conjunction with Applicants' Request for Continued Examination pursuant to 37 C.F.R. § 1.114 and in response to the Final Office Action mailed September 27, 2005, please amend the application as follows and consider the remarks set forth below.

Applicants hereby petition under the provisions of 37 C.F.R. § 1.136(a) for an extension of time in which to respond to the outstanding Office Action and include a fee as set forth in 37 C.F.R. § 1.17(a) with this response for such extension of time.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 7 of this paper.